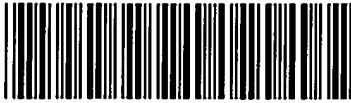


**Search Notes**

Application/Control No.

10/776,256

Examiner

Arnel C. Lavarias

Applicant(s)/Patent under  
Reexamination

CEMIC ET AL.

Art Unit

2872

**SEARCHED**

Class	Subclass	Date	Examiner

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
Interference search (See attached)		6/26/2006	ACL

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
356/614,615,616,622,399,400,401 Limited class search (See attached)	6/26/2006	ACL
359/454,455 Limited class search (See attached)	6/26/2006	ACL
362/551,554,558 Limited class search (See attached)	6/26/2006	ACL
EAST text search (See attached)	6/26/2006	ACL